



DE-64 Camera System

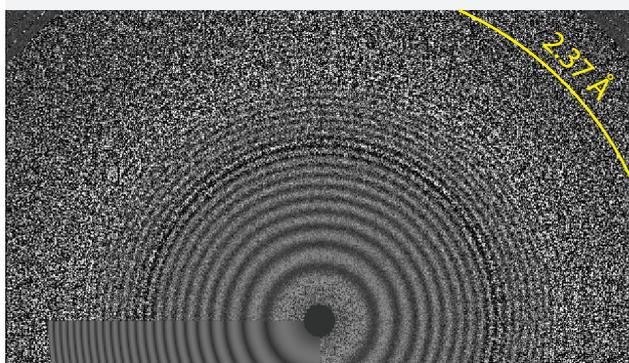
the ultimate direct detector for high-end TEMs

Direct Electron delivers | bigger | better | faster | cameras for electron microscopy

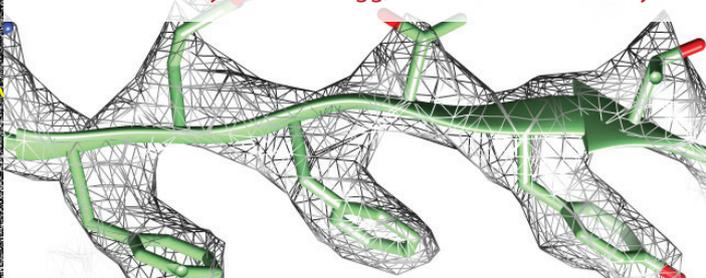
Better Science, Faster – Brilliant Results in Less Time

- Direct detection device (DDD[®]) delivers *high resolution and excellent sensitivity*.
- **8k × 8k** (67.1 million) pixels!
- Capture >4× more area in each image. Complete experiments >4× faster.
- **High-speed** continuous streaming for “movie-mode” processing (e.g., motion correction) and continuous-tilt tomography.
- **Unrivalled features:** integrated survey sensor & Faraday plate.
- **Electron counting** to maximize signal-to-noise ratio when needed.
- **The best of all the new TEM camera technology in a single integrated system.**
- Low total cost-of-ownership and exceptional support.

Microscopy
TODAY
INNOVATION AWARDS



Cryo-EM of AAV at 2.8 Å resolution (~85% Nyquist).
Courtesy of Scott Stagg, Florida State University.



Direct Electron[®]
NOVATION PROPELLING DISCOVERY



(주)한국아이티에스
Korea I.T.S. Co., Ltd.

서울특별시 송파구 백제고분로 101, 서일빌딩 4층

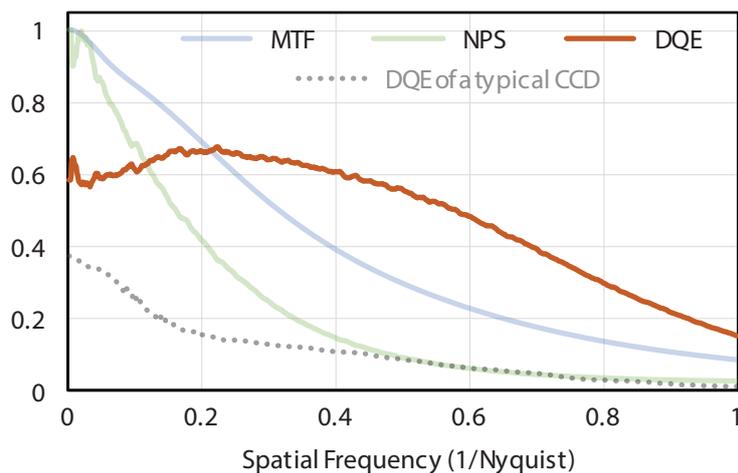
tel | 02-421-4022
fax | 02-421-9022
web | www.koreaits.com
web | www.directelectron.com

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detection electron energy	optimized for 80 keV – 1.25 MeV
pixel array specification	8192 × 8192 (67.1 million pixels) 6.5 μm pixel pitch
single electron SNR	~50:1 (300 kV)
sensor design	>3T pixel design with correlated double sampling (CDS) backthinned radiation hardened
acquisition frame rate	30 fps max, unbinned full-frame subarray readout up to 1920 fps max
acquisition modes	integrating mode counting mode (with optional counting system)
exposure rate	large dynamic range with consistent performance in integrating mode (e.g., 4 – 400 e-/pixel/s)
mounting position	fully retractable mounted on-axis TEM bottom port or in JEOL film drawer
“buddy” camera	integrated near-axis 2048 × 2048 scintillator-coupled survey sensor
exposure measurement	integrated Faraday plate for exposure measurement with each acquisition
sensor protection	integrated physical protection shutter microscope blanking/shuttering failsafe software
computer system	certified high-performance computer system with large >25 TB RAID array for data streaming
image format	image data stored in non-proprietary format to ensure broad compatibility
acquisition & processing software	<i>conventional acquisition:</i> DE-IM (full-featured, user-friendly) μManager (free, open-source) <i>in situ movie acquisition:</i> DE-StreamPix (continuous streaming) <i>automated acquisition:</i> Legikon SerialEM EMTTools (TVIPS) others using the DE SDK <i>“movie” processing:</i> DE image processing software (free, open-source, Python-based) others <i>customization:</i> software development kit (SDK) for integration with custom software

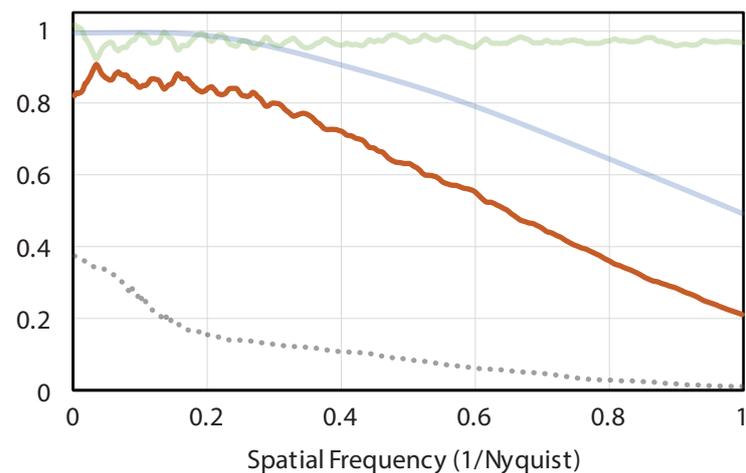
Integrating Mode

best for maximizing overall productivity



Electron Counting Mode

best for maximizing signal-to-noise ratio



* Note: Specifications and performance are subject to change.



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